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APPLICANTS

Mike Ravkin, Sunnyvale, CA;

John Boyd, Atascadero, CA;

Yezdi N. Dordi, Palo Alto, CA; Fred C. Redeker, Fremont, CA;

John M. de Larios, Palo Alto, CA;

** CONTINUING DATA *****

This application is a CIP of 10/330,843 12/24/2002
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HW KCS

** FOREIGN APPLICATIONS *****

HW Nore

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35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	Verified and Acknowledged <i>[Signature]</i> Examiner's Signature	Initials		

ADDRESS

25920
MARTINE PENILLA & GENCARELLA, LLP
710 LAKEWAY DRIVE
SUITE 200
SUNNYVALE, CA
94085

TITLE

Apparatus and method for depositing and planarizing thin films of semiconductor wafers

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